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## APPLICANTS

Tue Nguyen, Fremont, CA;

Tai Dung Nguyen, Fremont, CA;

\*\* CONTINUING DATA \*\*\*\*\*  
*None*\*\* FOREIGN APPLICATIONS \*\*\*\*\*  
*None*

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	CA	DRAWING 10	CLAIMS 20	CLAIMS 3
Verified and Acknowledged	Examiner's Signature <i>[Signature]</i> Initials <i>[Initials]</i>				

## ADDRESS

Sheldon R. Meyer  
 Fliesler Meyer LLP  
 Four Embarcadero Center  
 Fourth Floor  
 San Francisco , CA  
 94111-4156

## TITLE

Plasma semiconductor processing system and method

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue )
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